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# Giant reduction of InN surface electron accumulation: Compensation of surface donors by Mg dopants

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Extreme electron accumulation with sheet density greater than  $10^{13} \text{ cm}^{-2}$  is almost universally present at the surface of indium nitride (InN). Here, x-ray photoemission spectroscopy and secondary ion mass spectrometry are used to show that the surface Fermi level decreases as the Mg concentration increases, with the sheet electron density falling to below  $10^8 \text{ cm}^{-2}$ . Surface space-charge calculations indicate that the lowering of the surface Fermi level increases the density of unoccupied donor-type surface states and that these are largely compensated by Mg-acceptors in the near-surface hole depletion region rather than by accumulated electrons. This is a significant step towards the realization of InN-based optoelectronic devices.

Indium nitride (InN) and associated In-rich InGaN alloys have enormous potential for use in optoelectronic applications, such as high efficiency solar cells. However, these opportunities have yet to be exploited due to the difficulties achieving a *p-n* junction device in the presence of surface electron accumulation/inversion layers characterised by a sheet electron density in excess of  $10^{13} \text{ cm}^{-2}$  [1–4], with the exception of biasing via an electrolyte or ionic liquid [5]. This electron accumulation can be explained by the extremely low conduction band minimum at the  $\Gamma$  point of the Brillouin zone. Consequently the charge neutrality level (CNL) is located particularly high in the conduction band and the surface Fermi level is pinned below the CNL, resulting in an electron accumulation layer. In the majority of semiconductors, the CNL lies in the band gap at the  $\Gamma$  point, which leads to surface electron depletion for *n*-type doping. The electron accumulation has been observed at the surface of wurtzite In- and N-polar *c*-plane InN and non-polar *a*- and *m*-plane InN, as well as at the surface of zinc-blende InN(001) [2, 6]. Based on first-principles calculations, Segev and Van de Walle [7] proposed no electron accumulation layer would form at the surface of *a*-plane (11 $\bar{2}$ 0) and *m*-plane (1 $\bar{1}$ 00) InN in the absence of In adlayers. This lack of electron accumulation was reported on *in-situ* cleaved *a*-plane InN [8], but has not been observed on as-grown surfaces [2, 8–11]. However, recent reports suggest that the In adlayers at the surface of N-polar *c*-plane InN can be avoided under certain growth conditions or can be removed by chemical treatment. Such In adlayer-free N-polar surfaces have been shown to have much reduced electron accumulation [12, 13]. Additionally, the presence of an almost negligible level of electron accumulation has been reported at the lateral nonpolar surfaces of

some InN nanowires [14]. Interestingly, there have been no reports of the removal or significant reduction of the electron accumulation at the surface of In-polarity InN.

In this letter, we report significant lowering of the surface Fermi level in Mg-doped ( $> 1 \times 10^{19} \text{ cm}^{-3}$ ) InN(0001) thin films with increasing Mg-doping, indicating a large reduction of the electron accumulation. Surface space-charge calculations are used to determine the surface sheet electron density and donor surface state density as a function of Mg-doping level. As the Mg doping is increased, the donor surface state density increases, but it is increasingly compensated by near-surface Mg acceptors rather than by free electrons.

The Mg-doped In-polarity InN samples were grown by plasma-assisted molecular beam epitaxy (PA-MBE) with a range of Mg cell temperatures at the University of Canterbury, New Zealand. All 1200 nm thick films were grown on a *c*-plane sapphire substrate with a 3000–4000 nm GaN template layer, provided by Lumilog. The Mg concentration was determined by secondary ion mass spectrometry (SIMS) with an Atomika 4500 SIMS instrument using a 500 eV  $\text{O}_2^+$  ion beam in conjunction with an ion-implanted InN standard. Before loading into the x-ray photoelectron spectroscopy (XPS) vacuum chamber, the samples were subjected to etching in a 10 mol/l HCl solution for 60 s to reduce the oxide layers, followed by rinsing in deionized water and immediate drying in  $\text{N}_2$ . High-resolution XPS measurements were performed at room temperature using a monochromated Al  $K_\alpha$  x-ray source and a Scienta ESCA300 spectrometer at the National Centre for Electron Spectroscopy and Surface Analysis, Daresbury Laboratory, UK. The Fermi level was calibrated from the Fermi edge of an ion-bombarded silver reference sample; details of the spectrometer are re-



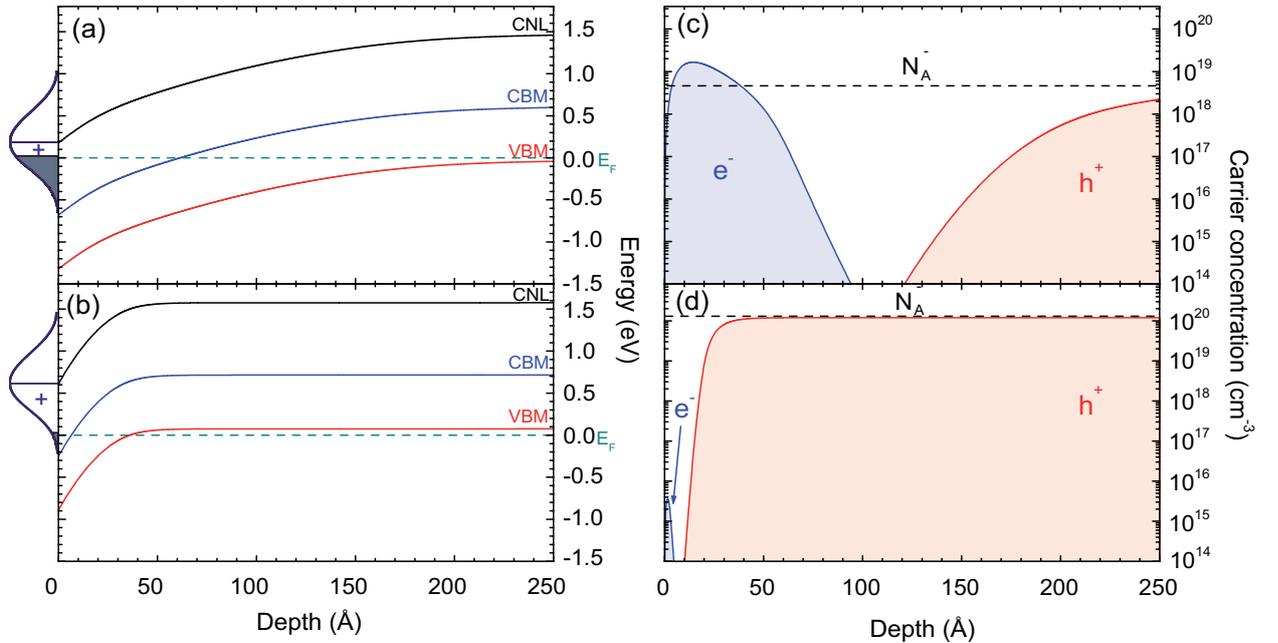


FIG. 3: (Color online) The conduction band minimum (CBM), valence band maximum and charge neutrality level (CNL) with respect to the Fermi level (dashed line), as a function of depth from the surface, for a Mg concentration of (a)  $4.7 \times 10^{18} \text{ cm}^{-3}$  and (b)  $1.2 \times 10^{20} \text{ cm}^{-3}$ . The CNL is located high above the CBM [26]. The shaded portion in each case represents filled neutral donor states. The portion labelled “+” represents the ionized donor states. (c) and (d) shows the carrier concentration profiles corresponding to (a) and (b), respectively.

from the area under the electron accumulation peak in the carrier concentration profile. From the calculated charge-depth profiles, the surface sheet electron densities,  $n_{2D}$ , for the samples with the highest Mg concentration have been found to be between  $7.9 \times 10^7 \text{ cm}^{-2}$  and  $2.5 \times 10^{10} \text{ cm}^{-2}$ , several orders of magnitude lower than for undoped InN [22], while for the moderately Mg doped InN films, the  $n_{2D}$  has been determined to be  $\sim 1.0 \times 10^{13} \text{ cm}^{-2}$ . The  $n_{2D}$  values as a function of Mg concentration are presented in Fig. 4 (a).

If the surface Fermi level,  $E_{Fs}$ , is located below the charge neutrality level (CNL), some of the higher-energy donor-like surface states will be unoccupied and hence positively charged. Incorporation of Mg into InN shifts the Fermi level towards the VBM [17] and hence reduces the fraction of donor-like surface states which are occupied. Consequently, the positively charged surface donor density increases which might be expected to result in an increased electron accumulation layer; however, the surface electron sheet density (accumulation layer) decreases rather significantly (see Fig. 4) as the Mg concentration increases. The surface, in an equilibrium state, must be neutral; therefore the positive surface charge must be balanced. This can be understood within the inversion layer model. Instead of surface electrons compensating the positively charged surface donor states, as in the electron accumulation case for  $n$ -type InN, this function is performed by the near-surface Mg acceptors,  $N_A^-$ .

For the highest Mg concentration, the surface electron sheet density is dramatically reduced, therefore the sample essentially exhibits a hole depletion layer (Fig. 3 (b) and (d)). Similar compensation of bulk Zn acceptors by positively charged surface P vacancies has been reported for the InP(110) surface [28], but without the enormous change from the generally observed surface space-charge layer that is reported here. It should also be noted that XPS core level spectra did not show any signal from Mg, indicating no significant Mg segregation to the surface of the films, the bulk doping concentration of Mg being too low for XPS to detect. This and the uniform Mg concentration seen in the SIMS profiles beneath the surface transient region support the use of a constant background acceptor density as a function of depth in the space-charge calculations.

As a result, for the case of  $n$ -type InN,  $n \sim 1 \times 10^{19} \text{ cm}^{-3}$  is the doping level (see Fig. 2) above which the  $E_{Fs}$  of undoped and Si-doped InN tends to increase to reduce the electron accumulation, producing flat bands and maintaining charge neutrality [26]. In the case of  $p$ -type InN, the  $E_{Fs}$  level tends to decrease to reduce the electron accumulation, producing a hole depletion layer and maintaining charge neutrality. Similar divergence of the surface Fermi level position with doping was previously observed for  $n$ - and  $p$ -type GaAs, the archetypal compound semiconductor [27]. However, rather than the surface states responsible for the space charge always be-

ing donors as in the InN case, for GaAs, the type of charged surface state changes from acceptors in  $n$ -type to donors in  $p$ -type GaAs. Equivalently, downward band bending is observed for InN for both  $n$ - and  $p$ -type doping, whereas upward band bending is present for  $n$ -type GaAs and downward for  $p$ -type. This difference is due to the respective positions of the CNL in these two materials, with that of InN lying above the conduction band minimum [26] and that of GaAs is just below the middle of the fundamental band gap [29, 30].

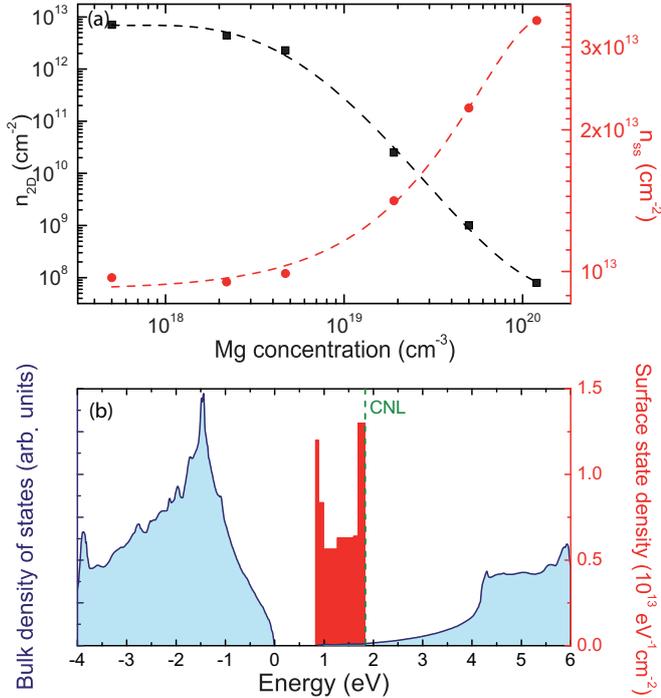


FIG. 4: (Color online) (a) Surface electron sheet density  $n_{2D}$  and donor-like ionized surface state density  $n_{ss}$  as a function of Mg concentration. (b) Surface state density (red histogram) as a function of energy. The height of each bar in the histogram is evaluated by taking the difference in surface state density between two successive samples and the width is determined by the difference between their surface Fermi levels. The bulk density of states (blue line) for InN calculated by Furthmüller *et al* [31], using quasiparticle-corrected density-functional theory is also shown.

By combining XPS measurements and space charge calculations, it is possible to determine the density of surface states as a function of energy for comparison with the theoretical predictions of Segev and Van de Walle [7, 32, 33]. For each of the Mg-doped, undoped and Si-doped samples, the surface Fermi level was measured by XPS and the unoccupied donor surface state density derived by solving the Poisson equation. A histogram profile of the density of states was then created by taking the difference between the surface state densities for successive pairs of samples over the energy range defined by the difference between their surface Fermi levels. The re-

sults are presented in Fig. 4(b) and plotted with the bulk density of states calculated using quasiparticle-corrected density-functional theory [31]. The lower energy peak is associated with the large differences in  $n_{ss}$  at high Mg concentrations, that is, from the data points for Mg concentrations of greater than  $1 \times 10^{19}$  cm<sup>-3</sup>. Similarly, the higher energy peak near the CNL is derived from the large differences in  $n_{ss}$  for InN samples with high Si concentrations of greater than  $1 \times 10^{19}$  cm<sup>-3</sup> which are associated with the surface Fermi levels shown in Fig. 2 and band bending values reported in Ref. [26]. The two peak structure of the experimentally determined surface density of states is in qualitative agreement with the theoretical surface density of states which was associated with In-In bonding in an In adlayer at the InN(0001) surface by Segev and Van de Walle [7, 32, 33].

In conclusion, we have demonstrated that incorporation of Mg as a dopant into InN redefines the bulk and surface electronic properties of this material. Previous results have shown that Si acts as a donor and its incorporation increases the bulk electron concentration. For  $n > 1 \times 10^{19}$  cm<sup>-3</sup>, the donor-like surface state density decreases and  $E_{F_s}$  saturates at the CNL, indicating a transition from an accumulation layer to flat bands. In contrast, Mg acts as an acceptor and its presence changes the type of conductivity from  $n$ -type to  $p$ -type. For  $[Mg] > 1 \times 10^{19}$  cm<sup>-3</sup>, the donor surface state density increases while  $E_{F_s}$  decreases; however, the surface sheet electron density decreases enormously, indicating a transition from electron accumulation to hole depletion for heavily Mg-doped InN. As the Mg concentration increases, the donor surface states are increasingly compensated by Mg near-surface acceptors in the hole depletion region. These results give positive indications for fabrication of InN  $p$ - $n$  junctions, because electron accumulation naturally disappears at high Mg doping levels.

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